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IN THE CLAIMS

Please cancel claims 14 and 24 without prejudice or disclaimer of their subject matter, and amend claims 1 and 16, as follows:

- 1. (Currently Amended) A field emission display, comprising: 1
- a first substrate; 2

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- an electron emission assembly arranged on said first substrate; 3
- a second substrate arranged a predetermined distance from said first substrate, said first and second substrates forming a vacuum space; 5
- an illumination assembly arranged on said second substrate, said illumination assembly being illuminated by electrons emitted from said electron emission assembly; [[and]] 8
 - a mesh grid arranged above said electron emission assembly, the mesh grid including an effective screen portion having a plurality of beam passage holes arranged in a predetermined pattern and having an inactive portion absent any beam passage holes; and
- a focusing electrode arranged on said mesh grid. 12
- 2. (Original) The field emission display of claim 1, wherein said mesh grid comprises 1 a metal. 2
 - 3. (Original) The field emission display of claim 1, wherein said mesh grid comprises

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- one of stainless steel, invar, and an iron-nickel alloy.
- 4. (Original) The field emission display of claim 3, wherein the iron-nickel alloy comprises 2.0 to 10.0 wt% of Cr.
- 5. (Original) The field emission display of claim 3, wherein the iron-nickel alloy comprises 40.0 to 44.0 wt% of Ni.
- 6. (Original) The field emission display of claim 3, wherein the iron-nickel alloy comprises 0.2 to 0.4 wt% of Mn, 0.7 wt% or less of C, and 0.3 wt% or less of Si.
 - 7. (Original) The field emission display device of claim 1, wherein the thermal expansion coefficient of said mesh grid is in the range of 9.0 x 10⁻⁶/°C to 10.0 x 10⁻⁶/°C.
 - 8. (Original) The field emission display device of claim 1, wherein electron emission assembly comprises a cathode and a gate and an electron emission source.
- 9. (Previously Presented) The field emission display device of claim 8, wherein said gate is arranged on an upper side of said cathode.
 - 10. (Previously Presented) The field emission display device of claim 8, wherein the

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- gate is arranged on a lower side of said cathode.
- 1 11. (Original) The field emission display device of claim 1, wherein an intermediate material is arranged between said electron emission assembly and said mesh grid.
- 1 12. (Previously Presented) The field emission display device of claim 11, wherein said intermediate material comprises an insulating material.
- 1 13. (Previously Presented) The field emission display device of claim 11, wherein said intermediate material comprises a resistive material.

Claim 14. (Canceled)

- 1 15. (Previously Presented) A field emission display device, comprising:
- 2 a first substrate;

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- 3 an electron emission assembly arranged on said first substrate;
- a second substrate arranged a predetermined distance from said first substrate, said first and second substrates forming a vaccum assembly;
 - an illumination assembly arranged on said second substrate, said illumination assembly being illuminated by electrons emitted from said electron emission assembly; and
- a mesh grid arranged above said electron emission assembly, the mesh grid including

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- an effective screen portion having a plurality of beam passage holes arranged in a predetermined pattern and having an inactive portion absent any beam passage holes;
- wherein said mesh grid is bonded to said electron emission assembly by a frit.
 - 16. (Currently Amended) A method of manufacturing a field emission display, the method comprising:
- 3 providing a first substrate;

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- arranging an electron emission assembly on said first substrate;
- arranging a second substrate a predetermined distance from said first substrate to form

 a vacuum space with said first and second substrates;
- arranging an illumination assembly on said second substrate, and illuminating said illumination assembly with electrons emitted from said electron emission assembly; [[and]]
 - arranging a mesh grid above said electron emission assembly, the mesh grid including an effective screen portion having a plurality of beam passage holes arranged in a predetermined pattern and having an inactive portion absent any beam passage holes; and
- 12 <u>a focusing electrode arranged on said mesh grid</u>.
- 1 17. (Original) The method of claim 16, further comprising forming said mesh grid of a metal.
 - 18. (Original) The method of claim 16, further comprising forming said mesh grid

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- of one of stainless steel, invar, and an iron-nickel alloy.
- 19. (Original) The method of claim 16, further comprising forming a cathode and a gate and an electron emission source in said electron emission assembly.
- 20. (Original) The method of claim 19, further comprising forming said gate on one of an upper an lower side of said cathode.
- 21. (Original) The method of claim 16, further comprising forming an intermediate material between said electron emission assembly and said mesh grid.
- 22. (Original) The method of claim 21, further comprising forming said intermediate material of an insulating material.
- 23. (Original) The method of claim 21, further comprising forming said intermediate material of a resistive material.

Claim 24. (Canceled)

25. (Previously Presented) A method of manufacturing a field emission display device, the method comprising:

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providing a first substrate;
arranging an electron emission assembly on said first substrate;
arranging a second substrate a predetermined distance from said first substrate to form
a vaccum assembly with said first and second substrates;
arranging an illumination assembly on said second substrate and illuminating said
illumination assembly with electrons emitted from said electron emission assembly;
arranging a mesh grid above said electron emission assembly the mesh grid including
an effective screen portion having a plurality of beam passage holes arranged in a
predetermined pattern and having an inactive portion absent any beam passage holes; and

bonding said mesh grid to said electron emission assembly with a frit.